

② Drafts

② Pending

② Active

② L1: (10) ("6324091") or ("6320200") or ("634
 ② L2: (271696) (organic or polymer).cim.
 ② L3: (18770) 2 and (etch\$3 or pattern\$3).cim.
 ② L4: (2921) 3 and (electrode.cim.)
 ② L5: (764) 4 and ((organic or polymer) near4 (9 and (etch\$3 near4 (organic or polymer))
 ② L6: (334) 5 and ((organic or polymer) near4 (9 and (etch\$3 near4 (organic or polymer))
 ② L7: (263) 6 and ((pattern\$3 or etch\$3) near3 (9 and (etch\$3 near4 (organic or polymer))
 ② L8: (132) 7 and (mask or resist or photoresis
 ② L9: (45) 8 and ((second or top or upper) adj
 ② L10: (28) 9 and (organic near9 electrode)
 ② L11: (28) 9 and (etch\$3 near9 (organic or polymer))

② Failed

② Saved

② (0) ("(thinadjfilm)nearresistor").PN.
 ② (0) ("(thinadjfilm)nearresistor").PN.
 ② (150130) thin adj film
 ② (14857) (thin adj film) and resistor
 ② (2054) ((thin adj film) and resistor) and ((thin adj film) and resistor)
 ② (1735) ((thin adj film) and resistor) and ((thin adj film) and resistor)

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2 L1: (9103) organic near4 (device or memory)
 2 L2: (6571) 1 and (organic or polymer).cim.
 2 L3: (2133) 2 and (electrode.cim.)
 2 L4: (1507) 3 and ((second or top or upper) ne
 2 L5: (1224) 4 and (etch\$3 or pattern\$3)
 2 L6: (451) 5 and ((etch43 or pattern\$3) near7
 2 L7: (189) 6 and (organic adj1 layer)
 2 L8: (360) 6 and (organic adj3 layer)
 2 L9: (234) 8 and ((etch\$3 or pattern\$3) adj4 o
 2 L10: (38) 9 and ((etch\$3 or pattern\$3) adj4 o
 2 L11: (33) 10 and (mask or resist or photoresi
 2 L12: (18) 11 and (mask or resist or photoresi
 2 L13: (409) 6 and (organic adj3 (film or layer
 2 L14: (102) 13 and (mask or resist or photoresi
 2 L15: (66) 14 and (silicon\$6)
 2 L16: (61) 15 and (electrode with organic)
 2 L17: (59) 16 and (electrode near9 organic)
 2 L18: (33) 17 and (organic adj2 (memory or dev
 2 L19: (31) 17 and (silicon\$6) resist or phot
 2 L20: (31) 17 and (silicon\$6) resist or phot

Failed

#	PTIN	Document ID	Issue Date	Pages	Title	Current US	Current EP	Patent Type	Inventor	C	C	C	C
1	Γ Γ Γ Γ Γ	US	20040325	30	Method for etching	438/710			Higuchi, Kenichi	✓	✓	✓	✓
2	Γ Γ Γ Γ Γ	US	20040058552	18	Display apparatus and method for fabricating	313/495	257/E21.70		Yamada, Jiro et al.	✓	✓	✓	✓
3	Γ Γ Γ Γ Γ	US	20030201708	21	Method of attaching layer material and form	438/34	313/944		Yamada, Tsutomu et al.	✓	✓	✓	✓
4	Γ Γ Γ Γ Γ	US	20020076847	16	Electroluminescent display device	428/690	313/505		Antoniadis, Homer et al.	✓	✓	✓	✓
	Γ Γ Γ Γ Γ	A	US 5902688	19990511			313/508						

- 3 Active
 - 3 L1: (2) ((67446899") or ("6737704")) .PN.
 - 3 L2: (4) ((6,278,148") or ("6,218,631") or ("5,610,403") or ("5,6458674") .PN.
 - 3 L3: (6) "6458674"
 - 3 L4: (1) ("6458674") .PN.
 - 3 L5: (10) ((6324091") or ("6320200") or ("6348700") or ("4663270") .PN.
 - 3 L6: (7) 5 and organic
 - 3 L7: (7) 5 and (organic or polymer)
 - 3 L8: (0) 7 and (siliconS5 with (resist or mask or photoresist))
 - 3 L9: (2) 7 and (resist or mask or photoresist)
 - 3 L10: (160890) electrode.clm.
 - 3 L11: (14192) 10 and (organic or polymer).clm.
 - 3 L12: (1241) 11 and (resist or photoresist or mask).clm.
 - 3 L13: (983) 12 and (patternS3 or etchS3).clm.
 - 3 L14: (408) 13 and ((resist or photoresist or mask) with (silicon or organic or polymer)) .clm.
 - 3 L15: (201) 14 and ((organic or polymer) with electrode)
 - 3 L16: (199) 15 and ((etchS3 or patternS3) with (electrode or organic or polymer)) .clm.
 - 3 L17: (199) 15 and ((etchS3 or patternS3) same (electrode or organic or polymer)) .clm.
 - 3 L18: (62) 17 and (memory or ((second or top or upper) adj electrode)) .clm.
 - 3 L19: (62) 18 and (resist or mask or photoresist).clm.
 - 3 L20: (62) 19 and (etchS3 or patternS3).clm.
 - 3 L21: (62) 20 and ((etchS3 or patternS3) near10 (resist or mask or organic or polymer)) .clm.
 - 3 L22: (60) 20 and ((etchS3 or patternS3) near10 (organic or polymer)) .clm.
 - 3 L23: (59) 22 and ((etchS3 or patternS3) near5 (organic or polymer)) .clm.
 - 3 L24: (29) 23 and polymer
 - 3 L25: (7) 12 and (polysiloxane or silsesquioxane)
 - 3 L26: (1) 11 and ((resist or photoresist or mask) with (polysiloxane or silsesquioxane)) .clm.
 - 3 L27: (463) 12 and ((resist or mask or photoresist) near8 (silicon or organic or polymer)) .clm.
 - 3 L28: (178) 27 and (organic with electrode)
 - 3 L29: (178) 28 and (organic or polymer).clm.
 - 3 L30: (129) 29 and ((organic or polymer) near8 electrode)
 - 3 L31: (40) 30 and ((top or second or upper) adj electrode)
 - 3 L32: (16) 31 and dielectric
 - 3 L33: (37) 31 and ((top or second or upper) adj electrode).clm.
 - 3 L34: (32) 33 and (etchS3 or patternS3).clm.
 - 3 L35: (32) 34 and (resist or mask or photoresist).clm.